IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re P	atent A	ppiica	ITION OT:			
Hyun-l	Kwan C	hung	et al.			
Application No.:				Group Art Unit:		
Filed:	March	30, 20	004	Examiner:		
For:	INFORMATION STORAGE MEDIUM CONTAINING ENHANCED AV(ENAV) BUFFER CONFIGURATION INFORMATION, REPRODUCING METHOD THEREOF AND METHOD FOR MANAGING THE BUFFER					
INFORMATION DISCLOSURE STATEMENT						
PO Bo Alexar	iissione x 1450 ndria, V		Patents 13-1450			
Sir:						
subjec	ed certa t U.S. p	ain info atent	ormation that the Examiner may	ovisions of 37 CFR § 1.56, there is hereby consider material to the examination of the the Examiner make this information of record pject application.		
	1.	Encl	osures accompanying this Inforr	nation Disclosure Statement are:		
	1b. 1c. 1d.		application or a PCT Internation English language translation (deach non-English language pu Explanations of Relevancy of F	omplete or relevant portion(s)) attached to blication. References (ATTACHMENT 1(e), hereto) for of each non-English publication.		
	2. 🗌	In a und	ccordance with 37 CFR § 1.98, erstood to be the relevance of e	a concise explanation of what is presently ach non-English language publication is		
	2a.		enclosed "English-language ve indicates the degree of relevan 609, Minimum Requirements for	s 2a, 2b, 2c and/or 2d) sh language publications were cited on the rsion of the search report or action which ce found by the foreign office". (See MPEP or an Information Disclosure Statement, Part elevance, pp. 600-100 to 600-101, Rev. 1,		

	2b. [set forth in the application.
	2c. [satisfied because an English language translation (complete or relevant portion(s)) is attached to each non-English language publication.
2d. enclosed as Attachment 1(e), hereto.			
3. No admission is made that the information cited in this Statement is, or is considered to be, material to patentability nor a representation that a search has been made (other than search report(s) from a counterpart foreign application or a PCT International Search Report, if submitted herewith). 37 CFR §§ 1.97(g) and (h).			
			Respectfully submitted,
			STAAS & HALSEY LLP
Dated:	York on, D. e: (202	C. 2 2) 43	Michael D. Stein 20005 Registration No. 37,240 34-1500

ATTACHMENT	1(f)
T APPLICATION NO.	ו ו

	1793.1239	
LIST OF COPENDING APPLICATIONS	Hyun-Kwan Chung et al.	
	FILING DATE	GROUP ART UNIT
	March 30, 2004	

T ATTORNEY DOCKET NO.

The following, prior-filed, copending U.S. patent application(s) is/are listed in accordance with the duty of disclosure provisions of 37 CFR § 1.56, so that the Examiner may consider same should he deem any thereof to be material to examination of the subject application. Pursuant to 37 CFR 1.98(a)(2)(iii), a copy of the identified copending application(s) is provided.

It is requested that the Examiner acknowledge his consideration of application(s) below-listed by initialling same in the space provided adjacent each such application and that the Examiner sign and date this form at the bottom thereof to confirm such consideration having been given.

This submission in no way represents an admission that any of the information listed herein constitutes prior art with respect to the subject application and unless and until such prior art status is established, this submission is not a request that the information presented herein be printed on the face of any patent issuing from the subject application in which this information is being filed.

U.S. PATENT APPLICATION DOCUMENTS

*EXAMINER INITIAL		U.S. SERIAL NO.	FILING DATE	NAME	ASSIGNEE
GW/	1	10/647,445	August 26, 2003	Jung et al.	Samsung Electronics Co., Ltd.
/GW/	2	10/165,427 (Published as 2003/0012558)	June 10, 2002	Kim et al.	Samsung Electronics Co., Ltd.
/GW/	3	10/170,419 (Published as 2003/0049017)	June 14, 2003	Chung et el	Samsung Electronics Co., Ltd.
/GW/	4	10/277,094 (Published as 2003/0084460)	October 22, 2002	Chung et al	Samsung Electronics Co., Ltd.
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	7	-			
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EXAMINER	DATE CONSIDERED			
/Girumsew Wendmagegn/	10/26/2009			
*FXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through				

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.